

SURFACE-EMITTING LASER DEVICES WITH  
INTEGRATED BEAM-SHAPING OPTICS AND  
POWER-MONITORING DETECTORS

Abstract of the Disclosure

5           A semiconductor surface-emitting laser device  
has a lasing section and a beam-deflecting section.  
The two sections are assembled adjacent to each other  
in close optical and physical proximity. The lasing  
section includes a horizontal laser cavity having  
10   faceted ends. The cavity emits horizontally  
propagating a light beam through one faceted end into  
the adjoining beam-deflecting section. The  
beam-deflecting section includes two mirror surfaces.  
The two mirror surfaces are oriented such that the  
15   horizontally propagating light beam is redirected to  
propagate vertically toward the top surface of the  
laser device by sequential reflections off of the two  
mirrors. A beam-shaping micro-optics lens is disposed  
on the top surface of the beam-deflecting section. The  
20   micro-optic lens collimates the vertically propagating  
redirected light beam to generate an output beam  
emitted from the top surface of the laser device.

          Optionally, the laser device may have an  
integrated power-monitoring detector. The detector  
25   may, for example, be a photodetector built in the  
beam-deflecting section.